17. A method of making a nanostructure according to claim 1, performed in a substantially continuous manner.

18. An article made from the method according to claim 1.

19. An article according to claim 18 having an average surface reflectance of less than about 2% from 450 to 650 nm.

20. An article according to claim 18, wherein the nanostructure has a dimension of less than about 400 nanometers.

21. An article according to claim 20, wherein the nanostructure has a dimension of less than about 40 nanometers.

22. An article according to claim 18 comprising a Fresnel lens.

23. A solar panel comprising an article according to claim 22.

24. An article according to claim 1~~7~~9 wherein the percentage of light at 450 nm transmitted through the localized nanostructured surface that is deflected more than 2.5 degrees from the direction of incoming beam is less than 2.0%.